



08-01-05

IFW

Attorney Docket No. 08-279

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Sei-Hyung Ryu

Serial No.: 10/698,170

Filed: October 30, 2003

For: **VERTICAL JFET LIMITED SILICON CARBIDE POWER METAL-OXIDE  
SEMICONDUCTOR FIELD EFFECT TRANSISTORS (AS AMENDED)**

Group Art Unit: 2818

Confirmation No. 2502

Examiner: Long K. Tran

Date: July 29, 2005

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

Applicant provides the present Amendment to address the issues raised in the Office Action mailed July 12, 2005.

If any extension of time for the accompanying Amendment and Response is required, Applicants request that this be considered a petition therefore. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to Deposit Account No. 50-0220.

**Amendments to the Title** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.

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**Amendments to the Title:**

Please replace the title with the following amended title:

**VERTICAL JFET LIMITED SILICON CARBIDE POWER METAL-OXIDE  
SEMICONDUCTOR FIELD EFFECT TRANSISTORS ~~AND METHODS OF~~  
~~FABRICATING VERTICAL JFET SILICON CARBIDE METAL-OXIDE~~  
~~SEMICONDUCTOR FIELD EFFECT TRANSISTORS~~**